

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicants:** **Toshimichi Kurihara, et al.**

**Examiner:** **Nema O. Berezny**

**Serial No.:** **09/942,445**

**Group:** **2813**

**Filed:** **August 30, 2001**

**Docket:** **14872**

**For:** **SEMICONDUCTOR DEVICE IN A  
RESIN SEALED PACKAGE WITH  
A RADIATING PLATE AND  
MANUFACTURING METHOD THEREOF**

**Dated:** **February 24, 2004**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**STATEMENT PURSUANT  
TO 37 C.F.R. § 1.97(c)(1) and (e)(1)**

Sir:

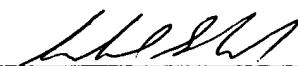
I hereby state that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

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**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on February 24, 2004.

Dated: February 24, 2004

  
Aasheesh V. Shravah

Accordingly, it is respectfully requested that the accompanying Information Disclosure Statement be considered with respect to the above-identified application.

Respectfully submitted,



Aasheesh V. Shravah  
Registration No. 54,445

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February 9, 2004

Dr. Dieter Heunemann  
Vossius & Partner  
Sieberstrasse 3  
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Germany

Re.: European Pat. Appln. No. 01 12 0654.7  
Your Ref.: F2565EP  
Our Ref.: 01FN041EPC

Dear Dr. Wenzel:

Thank you for your letter of February 4, 2004 enclosing a copy of the Search Report of the above-identified European application.

In order to accomplish the duty to disclose information under 37 C.F.R. 1.56(a) in the corresponding U. S. application, we would appreciate it if you could send with a copy of this letter

(1) a copy of the Search Report, and  
(2) copies of all of the documents cited in the Search Report directly to the following U.S. patent attorney who is now handling the corresponding U.S. application:

U.S. Patent Application of  
Hideaki SHIRAI SHI  
Serial No. 09/942,445  
Their Ref.: 14872  
Our Ref. : 01FN041US

Mr. Paul J. Esatto, Jr.  
SCULLY, SCOTT, MURPHY & PRESSER  
400 Garden City Plaza  
Garden City, New York 11530-3319  
U. S. A.

By a copy of this letter, the U.S. patent attorney is requested that upon receipt of the above-mentioned documents from the European attorney, he file them with the U.S. PTO as an Information Disclosure Statement.

Very truly yours,

FUJIMAKI PATENT OFFICE

*Mikako Kurozaki*  
for Masanori FUJIMAKI  
Patent Attorney

cc: Mr. Paul J. Esatto, Jr.

MF/mk